

IN THE CLAIMS

1. (Currently amended) A passive alignment assembly configured to support at least one optical element to a pre-determined position, the assembly comprising:
 - a micromachined base having a first mating part;
 - a payload configured to support the optical element, the payload having a second mating part; and
 - a connecting structure configured to contact the first mating part of the base and the second mating part of the payload, wherein the connecting structure constrains the payload in about five to about six degrees of freedom with respect to the base,
wherein the connecting structure is formed from a substantially flat wafer.
2. (Original) The assembly of Claim 1, wherein the connecting structure constrains and positions the payload.
3. (Original) The assembly of Claim 1, wherein the constrained degrees of freedom are pre-determined as to position and attitude.
4. (Canceled)
5. (Original) The assembly of Claim 1, wherein the base, payload and connecting structure are fabricated using a lithographic micromachining process.
6. (Original) The assembly of Claim 1, wherein the base and the payload are formed from substantially flat silicon wafers.

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7. (Canceled)

8. (Currently amended) The assembly of Claim 1 20, wherein the base and the payload comprise substantially planar wafers.

9. (Currently amended) The assembly of Claim 1 20, wherein the base and the payload comprise substantially circular rings.

10. (Currently amended) The assembly of Claim 5 A passive alignment assembly configured to support at least one optical element to a pre-determined position, the assembly comprising:

a micromachined base having a first mating part;
a payload configured to support the optical element, the payload having a second mating part; and
a connecting structure configured to contact the first mating part of the base and the second mating part of the payload, wherein the connecting structure constrains the payload in about five to about six degrees of freedom with respect to the base,
wherein the base, payload and connecting structure are fabricated using a lithographic micromachining process and, wherein the six degrees of freedom comprise three orthogonal translational positions constrained to less than one micron and three orthogonal angular positions constrained to less than five arcseconds.

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11. (Original) The assembly of Claim 1, wherein the connecting structure comprises at least one internal flexure assembly.

12. (Original) The assembly of Claim 1, wherein the connecting structure comprises a set of at least two connecting elements, each connecting element having a first mating feature configured to contact the payload and a second mating feature configured to contact the base.

13. (Original) The assembly of Claim 12, wherein the set of connecting elements locally constrains the payload and the base in more than six degrees of freedom.

14. (Original) The assembly of Claim 12, wherein the set of connecting elements enforces planarity.

15. (Original) The assembly of Claim 12, wherein the set of connecting elements increases bending stiffness in the base and payload.

16. (Original) The assembly of Claim 1, wherein the connecting structure comprises at least three connecting elements, each connecting element having mating features that are configured to constrain the payload in at least one degree of freedom with respect to the base, wherein the connecting elements together are configured to constrain the payload in a total of six degrees of freedom.

17. (Original) The assembly of Claim 1, wherein the connecting structure comprises at least three connecting elements, each connecting element having mating features that are configured to constrain the payload in at least two degrees of freedom with respect to the base, wherein the connecting elements together constrain the payload in a total of more than six degrees of freedom.

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18. (Original) The assembly of Claim 1, wherein the connecting structure comprises at least three connecting elements, each connecting element having mating features that are configured to constrain the payload in at least one degree of freedom with respect to the base, wherein the connecting elements together constrain the payload in a total of less than six degrees of freedom.

19. (Previously presented) The assembly of Claim 18, wherein the connecting elements provide a desired trajectory of motion for the payload with respect to the base.

20. (Currently amended) The assembly of Claim 1 A passive alignment assembly configured to support at least one optical element to a pre-determined position, the assembly comprising:

a micromachined base having a first mating part;

a payload configured to support the optical element, the payload having a second mating part; and

a connecting structure configured to contact the first mating part of the base and the second mating part of the payload, wherein the connecting structure constrains the payload in about five to about six degrees of freedom with respect to the base,
wherein the connecting structure comprises at least three connecting elements, each connecting element having mating features that are configured to constrain the payload in at least two degrees of freedom with respect to the base, wherein at least one connecting element is configured as an optical bench configured to support at least one optical element.

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21. (Original) The assembly of Claim 1, wherein the connecting structure comprises at least three connecting elements, each connecting element having mating features that are configured to constrain the payload in at least two degrees of freedom with respect to the base, wherein at least one connecting element has an internal flexure assembly.

22. (Original) The assembly of Claim 1, wherein the connecting structure comprises at least three connecting elements, each connecting element having mating features that are configured to constrain the payload in at least two degrees of freedom with respect to the base, wherein at least one connecting element has:

a first internal flexure assembly near a first end of the connecting element, the first end configured to contact the base, and

a second internal flexure assembly near a second end of the connecting element, the second end configured to contact the payload.

23. (Original) The assembly of Claim 1, wherein the connecting structure comprises at least three connecting elements, each connecting element having mating features that are configured to constrain the payload in at least two degrees of freedom with respect to the base, wherein at least one connecting element has a plurality of attachment points.

24. (Original) The assembly of Claim 1, wherein the connecting structure comprises at least three connecting elements, each connecting element having mating features that are configured to constrain the payload in at least two degrees of freedom with respect to the base, wherein at least one connecting element is itself pseudo-kinematically supported.

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25. (Currently amended) The assembly of Claim 1 A passive alignment assembly configured to support at least one optical element to a pre-determined position, the assembly comprising:

a micromachined base having a first mating part;

a payload configured to support the optical element, the payload having a second mating part; and

a connecting structure configured to contact the first mating part of the base and the second mating part of the payload, wherein the connecting structure constrains the payload in about five to about six degrees of freedom with respect to the base,
wherein the base comprises an internal flexure assembly configured to apply a preload to maintain contact between the first mating part and the connecting structure.

26. (Original) The assembly of Claim 25, wherein the internal flexure assembly comprises:

a set of motion flexures; and

a preloader stage coupled to the set of motion flexures, wherein the set of motion flexures provides one soft degree of freedom for the preloader stage to receive a deflection and apply a preload.

27. (Currently amended) The assembly of Claim 1 A passive alignment assembly configured to support at least one optical element to a pre-determined position, the assembly comprising:

a micromachined base having a first mating part;

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a payload configured to support the optical element, the payload having a second mating part; and

a connecting structure configured to contact the first mating part of the base and the second mating part of the payload, wherein the connecting structure constrains the payload in about five to about six degrees of freedom with respect to the base,
wherein the payload comprises an internal flexure assembly configured to apply a preload to maintain contact between the second mating part and the connecting structure.

28. (Original) The assembly of Claim 27, wherein the internal flexure assembly comprises:

a set of motion flexures; and

a preloader stage coupled to the set of motion flexures, wherein the set of motion flexures provides one soft degree of freedom for the preloader stage to receive a deflection and apply a preload.

29. (Currently amended) The assembly of Claim 1 A passive alignment assembly configured to support at least one optical element to a pre-determined position, the assembly comprising:

a micromachined base having a first mating part;

a payload configured to support the optical element, the payload having a second mating part; and

a connecting structure configured to contact the first mating part of the base and the second mating part of the payload, wherein the connecting structure constrains the payload in about five to about six degrees of freedom with respect to the base,

wherein the connecting structure comprises an internal flexure assembly configured to apply a preload to maintain contact between the first mating part and the connecting structure.

30. (Original) The assembly of Claim 29, wherein the internal flexure assembly comprises:

a set of motion flexures; and

a preloader stage coupled to the set of motion flexures, wherein the set of motion flexures provides one soft degree of freedom for the preloader stage to receive a deflection and apply a preload.

31. (Currently amended) The assembly of Claim 1 A passive alignment assembly configured to support at least one optical element to a pre-determined position, the assembly comprising:

a micromachined base having a first mating part;

a payload configured to support the optical element, the payload having a second mating part; and

a connecting structure configured to contact the first mating part of the base and the second mating part of the payload, wherein the connecting structure constrains the payload in about five to about six degrees of freedom with respect to the base, wherein the connecting structure comprises an internal flexure assembly configured to apply a preload to maintain contact between the second mating part and the connecting structure.

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32. (Original) The assembly of Claim 31, wherein the internal flexure assembly comprises:

a set of motion flexures; and

a preloader stage coupled to the set of motion flexures, wherein the set of motion flexures provides one soft degree of freedom for the preloader stage to receive a deflection and apply a preload.

33. (Original) The assembly of Claim 1, wherein an adhesive attaches the connecting structure to the first mating part of the base and to the second mating part of the payload.

34. (Original) The assembly of Claim 1, wherein the base comprises a substrate with a plurality of receptacles, each receptacle being configured to position an optical element.

35. (Original) The assembly of Claim 1, wherein the payload comprises a substrate with a plurality of receptacles, each receptacle being configured to position an optical element.

36. (Original) The assembly of Claim 1, wherein the base comprises a substrate with at least a first receptacle, the payload comprises a substrate with at least a second receptacle, the pairing of the first receptacle and the second receptacle being configured to position an optical element with about six constrained degrees of freedom.

37. (Currently amended) The assembly of Claim 1 A passive alignment assembly configured to support at least one optical element to a pre-determined position, the assembly comprising:

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a micromachined base having a first mating part;
a payload configured to support the optical element, the payload having a
second mating part; and
a connecting structure configured to contact the first mating part of the base
and the second mating part of the payload, wherein the connecting structure constrains
the payload in about five to about six degrees of freedom with respect to the base,
wherein the base further comprises a thermal compensation flexure assembly, the
thermal compensation flexure assembly being configured to limit distortions due to
temperature changes in an attached optical component.

38. (Currently amended) The assembly of Claim 1 A passive alignment assembly
configured to support at least one optical element to a pre-determined position, the assembly
comprising:

a micromachined base having a first mating part;
a payload configured to support the optical element, the payload having a
second mating part; and
a connecting structure configured to contact the first mating part of the base
and the second mating part of the payload, wherein the connecting structure constrains
the payload in about five to about six degrees of freedom with respect to the base,
wherein the base further comprises a strain isolation flexure assembly, the strain
isolation flexure assembly being configured to limit strains and distortions in the base
imposed by a supporting structure.

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39. (Original) The assembly of Claim 1, wherein the optical element is an optical
fiber.

40. (Original) The assembly of Claim 1, wherein the optical element is a lens.

41. (Original) The assembly of Claim 1, wherein the optical element is a mirror.

42. (Original) The assembly of Claim 1, wherein the optical element is a diode.

43. (Original) The assembly of Claim 1, wherein the first mating part and the second mating part comprise slots configured to receive tabs of the connecting structure.

44. (Original) The assembly of Claim 1, wherein the first mating part and the connecting structure form a slip-fit joint assembly.

45. (Original) The assembly of Claim 1, wherein the second mating part and the connecting structure form a slip-fit joint assembly.

46. (Original) The assembly of Claim 1, wherein the connecting structure comprises an internal flexure assembly configured to relieve stiffness in predetermined degrees of freedom.

47. (Original) The assembly of Claim 46, wherein the connecting structure comprises a ball joint flexure assembly.

48. (Canceled)

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49. (Currently amended) An assembly configured to position at least one optical element to a pre-determined position, the assembly comprising:

- a micromachined base having a first mating part;
- a payload configured to position the optical element, the payload having a second mating part; and
- a connecting structure configured to contact the first mating part of the base and the second mating part of the payload, wherein the connecting structure constrains the payload in at least one degree of freedom with respect to the base, such that a trajectory of the payload relative to the base is relatively unconstrained in less than six degrees of freedom, wherein the connecting structure includes linear actuators in additional degrees of freedom configured to form a motion control stage.

50. (Original) The assembly of Claim 49, wherein the connecting structure comprises a set of parallel connecting elements.

Claims 51-64 (Cancelled).

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